



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

COPY

In re PATENT APPLICATION of  
Inventor(s): TSUJI et al.

Appln. No.:	09	886,475
Series Code	↑	↑ Serial No.

Group Art Unit: Unassigned

Filed: June 22, 2001

Examiner: Unassigned

Title: MANAGING APPARATUS AND MANAGING METHOD  
OF A SEMICONDUCTOR MANUFACTURING APPARATUS

Atty. Dkt. P	281417	EL01003CDC
M#		Client Ref

Date: October 15, 2001

**SUBMISSION OF PRIORITY  
DOCUMENT IN ACCORDANCE  
WITH THE REQUIREMENTS OF RULE 55**

Hon. Asst Commissioner of Patents  
Washington, D.C. 20231

Sir:

Please accept the enclosed certified copy(ies) of the respective foreign application(s) listed below for which benefit under 35 U.S.C. 119/365 has been previously claimed in the subject application and if not is hereby claimed.

<u>Application No.</u>	<u>Country of Origin</u>	<u>Filed</u>
2000-153152	Japan	May 24, 2001

Respectfully submitted,

Pillsbury Winthrop LLP  
Intellectual Property Group

1600 Tysons Boulevard  
McLean, VA 22102  
Tel: (703) 905-2000

By Atty:	<u>Dale S. Lazar</u>	Reg. No.	<u>28872</u>
Sig:		Fax:	(703) 905-2500
		Tel:	(703) 905-2126

Atty/Sec: DSL/jjg



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PATENT OFFICE  
JAPANESE GOVERNMENT

This is to certify that the annexed is a true copy  
of the following application as filed with this office.

Date of Application: May 24, 2000

Application Number: Japanese Patent Application  
No. 2000-153152

Applicant(s): TOKYO ELECTRON LIMITED

June 4, 2001

Commissioner,  
Patent Office

Kouzo Oikawa (Seal)

Certificate No.2001-3052072

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日本国特許庁  
JAPAN PATENT OFFICE

別紙添付の書類に記載されている事項は下記の出願書類に記載されている事項と同一であることを証明する。

This is to certify that the annexed is a true copy of the following application as filed with this Office

出願年月日  
Date of Application:

2000年 5月24日

出願番号  
Application Number:

特願2000-153152

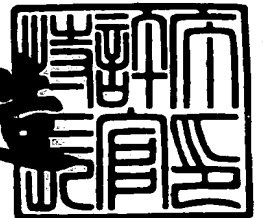
出願人  
Applicant(s):

東京エレクトロン株式会社

2001年 6月 4日

特許庁長官  
Commissioner,  
Japan Patent Office

及川耕造



出証番号 出証特2001-3052072